



Attorney Docket No. 0756-2422

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Hideto OHNUMA

Serial No. 10/053,572

Filed: January 24, 2002

For: METHOD OF MANUFACTURING
SEMICONDUCTOR DEVICE

) Group Art Unit: 2812

) Examiner: J. Kennedy

) CERTIFICATE OF MAILING

) I hereby certify that this correspondence is being
) deposited with the United States Postal Service
) with sufficient postage as First Class Mail in an
) envelope addressed to: Commissioner for Patents,
) P.O. Box 1450, Alexandria, VA 22313-1450, on
) December 3, 2003.

Adelle M. Stampen

AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated October 31, 2003, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 11 of this paper.